Docket No. 240394US-90 CONT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Tomoko	OHTSUKI ET AL.	GAU:	
SERIAL NO: NEW APPLICATION		EXAMINER:	
FILED: HEREWITH			
APPARATUS AND EX	AND WAVELENGTH STABI POSURE METHOD, METHOI JRING METHOD AND DEVIC	ILIZING CONTROL METHOD, EXPOSURI D OF MAKING EXPOSURE APPARATUS, CE	E AND
	REQUEST FOR PRICE	ORITY	
COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313			
SIR:			
	S. Application Serial Number 0 0.	09/831,345, filed June 28, 2001, is claimed pur	rsuant
☐ Full benefit of the filing date(s) of §119(e):	U.S. Provisional Application(s)  Application No.	) is claimed pursuant to the provisions of <b>35</b> U <u><b>Date Filed</b></u>	ı.s.c.
Applicants claim any right to prior the provisions of 35 U.S.C. §119,	rity from any earlier filed applica as noted below.	cations to which they may be entitled pursuant	to
In the matter of the above-identified ap	oplication for patent, notice is he	ereby given that the applicants claim as priorit	ty:
COUNTRY Japan Japan Japan Japan Japan Japan	APPLICATION NUMBER 11-257969 11-258089 11-259615 2000-153320 2000-190826	MONTH/DAY/YEAR September 10, 1999 September 13, 1999 September 13, 1999 May 24, 2000 June 26, 2000	
acknowledged as evidenced by  ☐ (A) Application Serial No.(s) w ☐ (B) Application Serial No.(s) ☐ are submitted herewith	nent of the Final Fee Serial No. filed Conal Bureau in PCT Application Constyle the International Bureau in a The attached PCT/IB/304.	timely manner under PCT Rule 17.1(a) has be	een
		Respectfully Submitted,  OBLON, SPIVAK, McCLELLAND,  MAIER & NEUSTADT, P.C.  Masayasu Mori	

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